

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

patent application of

Jason M. Benz

Serial No.: 09/695,028

Group Art Unit: 1765

Filing Date: October 24, 2000

Examiner: Alanko Anita Karen

For: METHOD FOR THIN FILM LASER REFLECTANCE CORRELATION FOR

SUBSTRATE ETCH ENDPOINT

Honorable Commissioner of Patents Alexandria, Virginia 22313-1450

SUBMISSION OF CORRECTED FORMAL DRAWINGS

Sir:

Submitted herewith are three (3) sheets of corrected formal drawings comprising figures 1A -8 for the above-identified patent application. Acknowledgment of receipt is respectfully requested. Please substitute these corrected formal drawings for the drawings which were filed with the application.

Respectfully submitted,

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